



**INTERNATIONAL
RELIABILITY PHYSICS SYMPOSIUM**

2002 TUTORIAL NOTES
Advanced Reliability Topics

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ADVANCED RELIABILITY TOPICS

- Topic 211. RELIABILITY ISSUES FOR ADVANCED SILICON TECHNOLOGIES
Anthony S. Oates, Agere
- Topic 212. MICROSTRUCTURE, PROCESSING AND RELIABILITY OF CU-BASED INTERCONNECT STRUCTURES
John Sanchez, AMD
- Topic 213. ESD PROTECTION AND FAILURE MECHANISMS IN RF TECHNOLOGY
Steven Voldman, IBM
- Topic 221. GATE OXIDE RELIABILITY
Paul Nicolian, Texas Instruments
- Topic 222. ANTENNA CHARGING (PID)
Srikanth Krishnan and Anand Krishnan, Texas Instruments
- Topic 223. ATOMIC SCALE DEFECTS INVOLVED IN MOS RELIABILITY PROBLEMS
Pat Lenahan, Penn State
- Topic 224. TRAP GENERATION PHENOMENA IN THIN DIELECTRICS UNDER ELECTRICAL STRESS
Gennadi Bersuker, SEMATECH
- Topic 231. RAMAN SPECTROSCOPY
Ingrid DeWolf, IMEC
- Topic 232. NEXT GENERATION IMAGING
Gay Samuelson, Intel
- Topic 233. DESIGNING MEMS/MOEMS FOR RELIABILITY
Susanne Arney et al., Lucent
- Topic 241. SILICON ANALOG/MIXED SIGNAL TECHNOLOGY RELIABILITY
Jae-Sung Rieh & Fernando Guarin, IBM
- Topic 242. FERROELECTRIC MATERIAL AND DEVICE RELIABILITY
Domokos Hadnagy, Ramtron
- Topic 243. 3.DETERMINATION OF GaAs MMIC RELIABILITY
Ken Decker, Triquint Semiconductor
- Topic 244. HBT
Tim Henderson, Triquint Semiconductor